
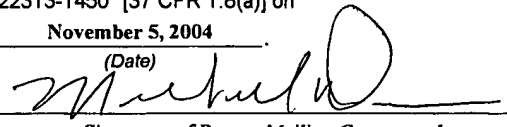


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TRANSMITTAL LETTER (General - Patent Pending)				Docket No. RDP101US	
In Re Application Of: Michael P. Dunn et al.					
Application No. 10/047,893	Filing Date January 14, 2002	Examiner Sean E. Vincent	Customer No. 24041	Group Art Unit 1731	Confirmation No. 5453
Title: METHOD FOR MAKING A SILICONE CARBIDE RESISTOR WITH SILICON / SILICON CARBIDE BY INDUCTION HEATING					
<u>COMMISSIONER FOR PATENTS:</u>					
Transmitted herewith is:					
1) Reply to Restriction Requirement 1) Certificate of Mailing by First Class Mail 1) Acknowledgement postcard					
in the above identified application.					
<input checked="" type="checkbox"/> No additional fee is required.					
<input type="checkbox"/> A check in the amount of _____ is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. 50-0822 as described below.					
<input type="checkbox"/> Charge the amount of _____					
<input type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional fee required.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.					
 _____ Signature			Dated: November 5, 2004		
Michael L. Dunn Reg. No. 25330 Simpson & Simpson, PLLC 5555 Main Street Williamsville, New York 14221 (716) 626-1564 Phone (716) 626-0366 Fax			<div style="border: 1px solid black; padding: 5px;"><p>I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on November 5, 2004 (Date)  _____ Signature of Person Mailing Correspondence Michael L. Dunn _____ Typed or Printed Name of Person Mailing Correspondence</p></div>		
cc:					



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

U.S. Patent Application No.: 10/047,893

Confirmation No.: 5453

Applicant(s): Michael P. Dunn et al.

Filed: January 14, 2002

For: METHOD FOR MAKING A SILICONE
CARBIDE RESISTOR WITH SILICON /
SILICON CARBIDE CONTACTS BY
INDUCTION HEATING

TC/Art Unit: 1731

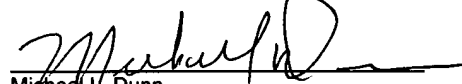
Examiner: Sean E. Vincent

Docket No.: RDP101US

Customer No.: 24041

Certificate of Mailing by First Class Mail

I certify that this Reply to Restriction Requirement is being deposited on November 5, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. §1.8 and is addressed to the Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.


Michael L. Dunn
Reg No. 25330

REPLY TO RESTRICTION REQUIREMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Honorable Sir:

This is a Reply to the Restriction Requirement dated October 5, 2004, restricting the claims to Group I, Claims 1-13 for a method for bonding silicon carbide and Group II, claims 14-16 drawn to our induction heating apparatus.

Applicants elect Group I claims 1-13 for examination without traverse.

Respectfully submitted,



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Dated: November 5, 2004